

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/590,618	PAN ET AL.	
Examiner	Art Unit	
DELTSANG SHIAO	1626	

SEARCHED					
Class	Subclass	Date	Examiner		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
restriction	6/30/2008	R.S.	